

Notice of References Cited	Application No. 10/04674	Applicant(s) ono el-al
	Examiner SMOLPUM	Group Art Unit 2817
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U.S. PATENT DOCUMENTS

☆		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A		5477325	12/95	MISHA SHITA et al	—	—
B		6117699	9/00	LEMOFF et al	—	—
C		639674	1/97	NOZAKI	—	—
D		5456361	9/99	IKEDA et al	—	—
E		552865	6/96	SHIWA	—	—
F		4426701	1/84	BOTER		
G						
H						
I						
J						
K						
L						
M						

FOREIGN PATENT DOCUMENTS

☆		DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N							
O							
P							
Q							
R							
S							
T							

NON-PATENT DOCUMENTS

☆		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
U		NARUI, "METALORGANIC VAPOR DEPOSITION OF ALGOLAS ON RIDGED SURFACES (100) SUBSTRATE FOR CRYSTAL THRESHOLD CURRENT LASER" JOURNAL OF CRYSTAL GROWTH 167 (1996) 452-457.	
W			
X			

* A copy of this reference is not being furnished with this Office action.
(See Manual of Patent Examining Procedure, Section 707.05(a).)